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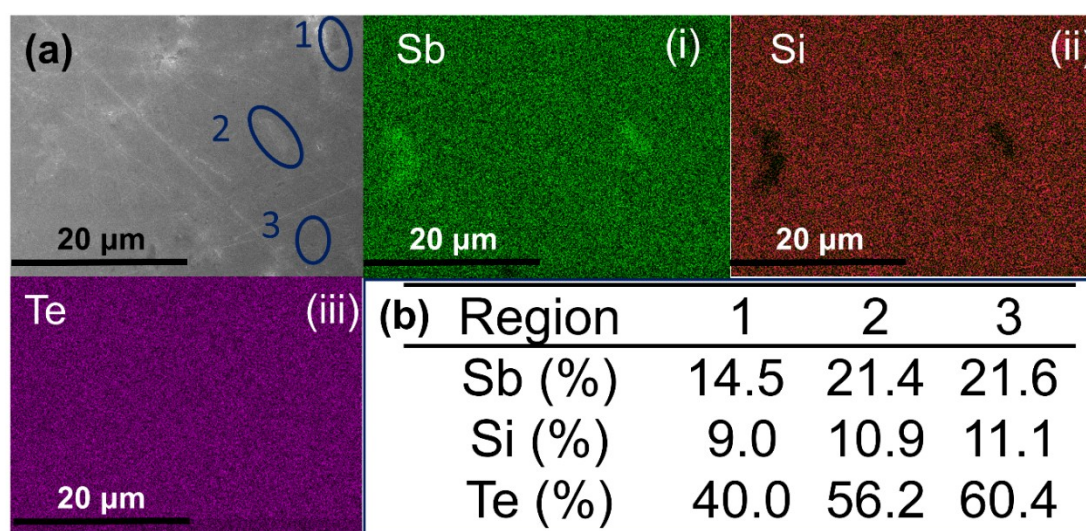
## Supporting Information – Improved Thermoelectric Efficiency of $\text{Sb}_2\text{Si}_2\text{Te}_6$ Through Yttrium Induced Nanocompositing

Received 00th January 20xx,  
Accepted 00th January 20xx

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DOI: 10.1039/x0xx00000x

### Structural Characterization



**Fig. S1** (a) The FESEM image of  $\text{Sb}_2\text{Si}_2\text{Te}_6$ . Elemental mapping images showing the distribution of (i) Sb, (ii) Si, and (iii) Te (b) Detailed quantification results revealing the atomic percent of each element.

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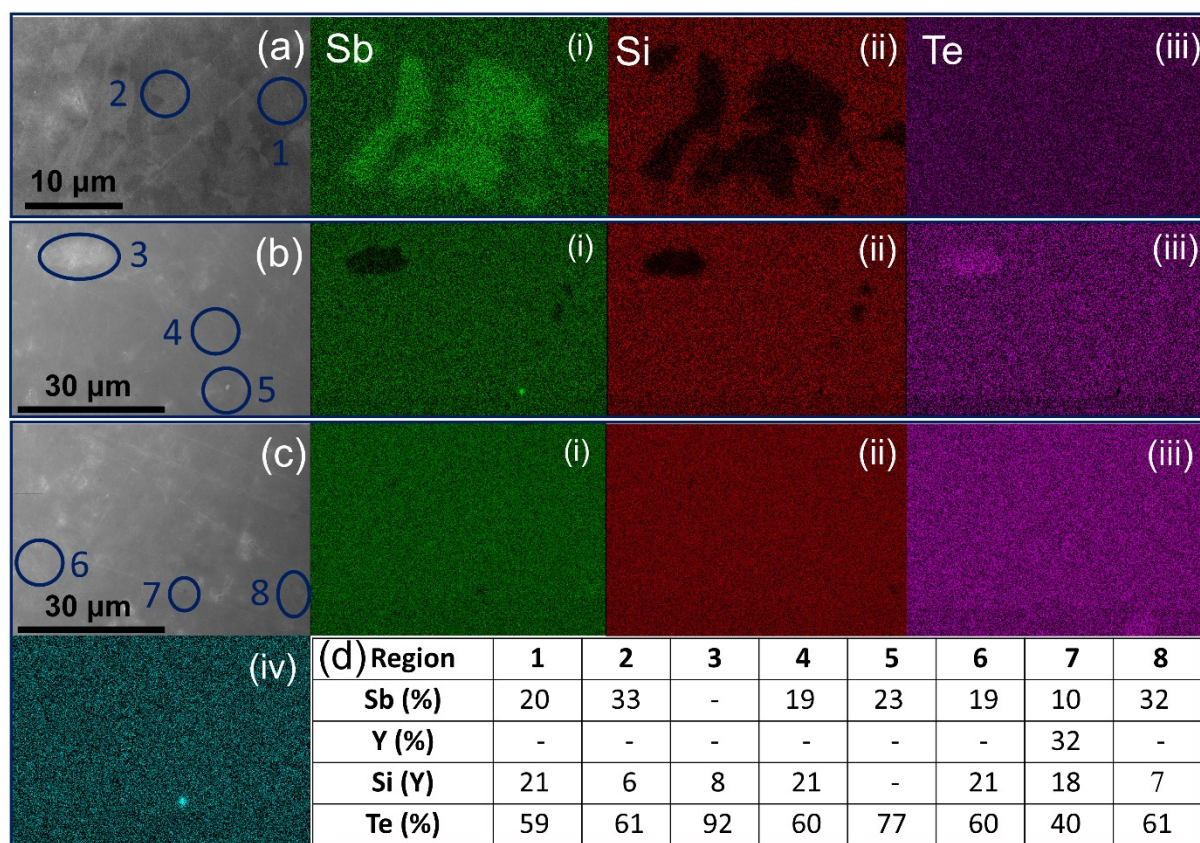
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† Supplementary Information available: [details of any supplementary information available should be included here]. See DOI: 10.1039/x0xx00000x



**Fig. S2** (a), (b), (c), the FESEM images of  $\text{Sb}_{1.98}\text{Y}_{0.02}\text{Si}_2\text{Te}_6$ . Elemental mapping images showing the distribution of (i) Sb, (ii) Si, (iii) Te and (iv) Y. (d) Detailed quantification results revealing the atomic percent of each element.

The nominal compositions of  $\text{Sb}_{2-x}\text{Y}_x\text{Si}_2\text{Te}_6$  were analyzed using EDS and XRF techniques. The findings are summarized in Table S1.

Table S2 Nominal, EDS determined and XRF determined compositions of  $\text{Sb}_{2-x}\text{Y}_x\text{Si}_2\text{Te}_6$ .

Nominal Composition	Composition from EDS	Composition from XRF
$\text{Sb}_2\text{Si}_2\text{Te}_6$	$\text{Sb}_{1.64}\text{Si}_2\text{Te}_{5.09}$	$\text{Sb}_{1.79}\text{Si}_2\text{Te}_{5.85}$
$\text{Sb}_{1.99}\text{Y}_{0.01}\text{Si}_2\text{Te}_6$	-	$\text{Sb}_{1.81}\text{Y}_{0.016}\text{Si}_2\text{Te}_{5.71}$
$\text{Sb}_{1.98}\text{Y}_{0.02}\text{Si}_2\text{Te}_6$	$\text{Sb}_{1.71}\text{Y}_{0.042}\text{Si}_2\text{Te}_{5.36}$	$\text{Sb}_{1.71}\text{Y}_{0.022}\text{Si}_2\text{Te}_{5.42}$
$\text{Sb}_{1.97}\text{Y}_{0.03}\text{Si}_2\text{Te}_6$	-	$\text{Sb}_{1.77}\text{Y}_{0.030}\text{Si}_2\text{Te}_{5.61}$

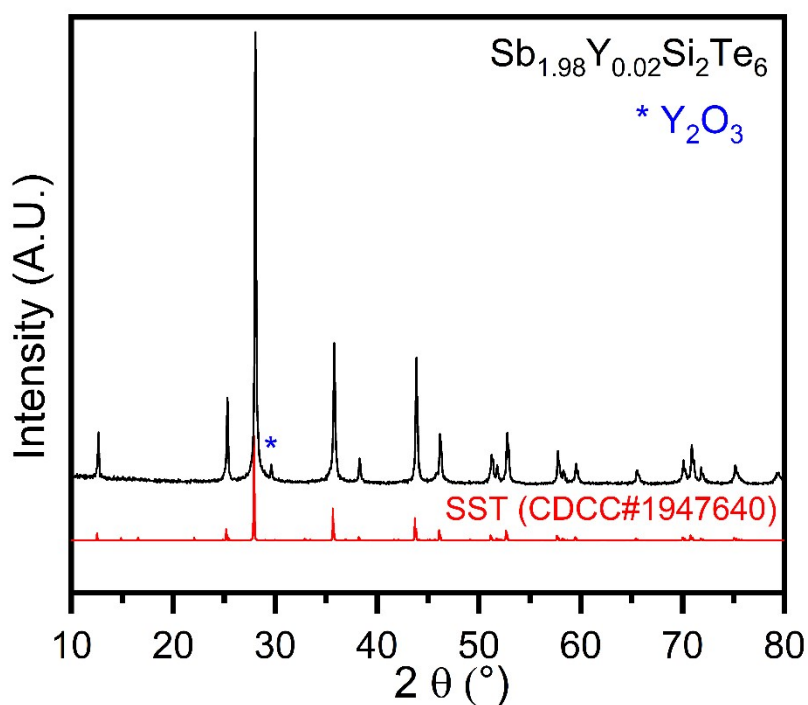


Fig. S3 Powder X-ray diffractogram of  $\text{Sb}_{1.98}\text{Y}_{0.02}\text{Si}_2\text{Te}_6$ , spanning from  $2\theta=10-80$ .

### Rietveld Refinement

In the Rietveld refinement, the structural model used was based on the Rietveld method. A Pseudo – Voigt function was applied to model the peak shapes and a linear interpolation approach was used for the background fitting. The Rietveld Refinement Quality indicators ( $\text{Chi}^2$ ,  $R_p$ ,  $R_{wp}$ ,  $R_{exp}$ ) of  $\text{Sb}_{2-x}\text{Y}_x\text{Si}_2\text{Te}_6$  are reported in Table S2.

Table S3 The Rietveld Refinement quality factors of  $\text{Sb}_{2-x}\text{Y}_x\text{Si}_2\text{Te}_6$  samples.

Nominal Composition	$\text{Chi}^2$	$R_p$	$R_{wp}$	$R_{exp}$
$\text{Sb}_2\text{Si}_2\text{Te}_6$	8.94	25.3	25.5	8.53
$\text{Sb}_{1.99}\text{Y}_{0.01}\text{Si}_2\text{Te}_6$	5.89	22.1	21.4	8.81
$\text{Sb}_{1.98}\text{Y}_{0.02}\text{Si}_2\text{Te}_6$	5.92	16.2	16.8	8.81
$\text{Sb}_{1.97}\text{Y}_{0.03}\text{Si}_2\text{Te}_6$	5.43	18.8	19.1	8.20

The graphical representations of the Rietveld Refinements of  $\text{Sb}_{2-x}\text{Y}_x\text{Si}_2\text{Te}_6$  are reported in Fig S4.

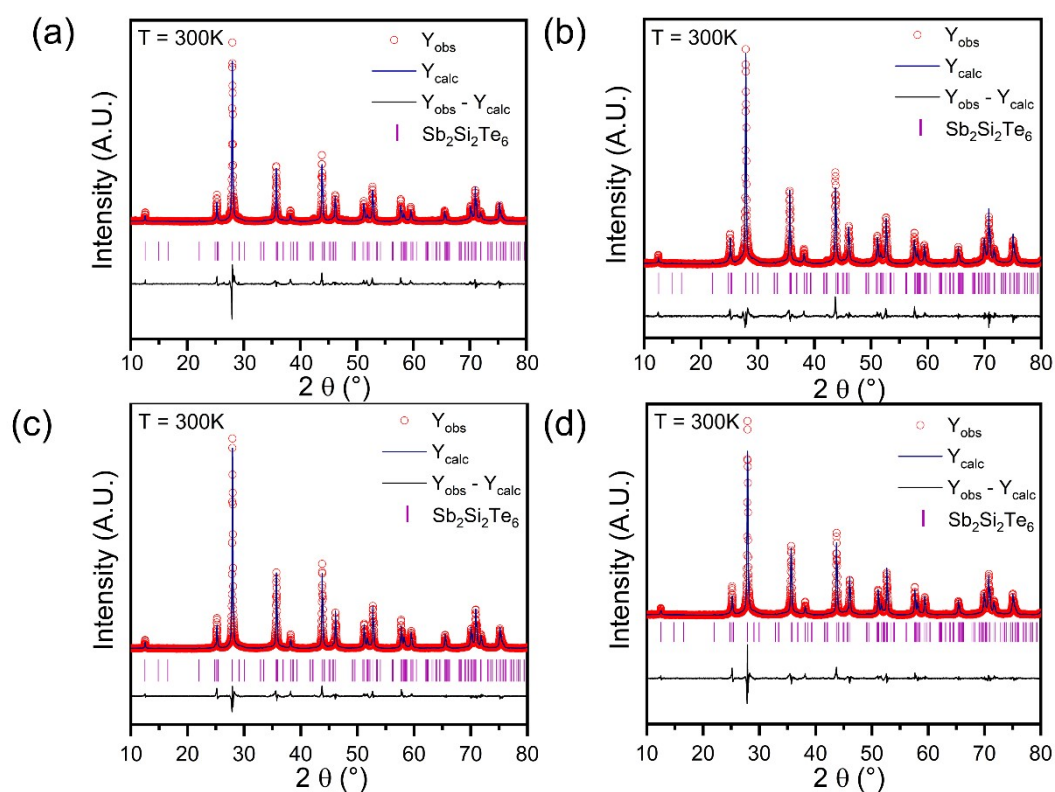


Fig. S4 The graphical representation of Rietveld Refinement of (a)  $\text{Sb}_2\text{Si}_2\text{Te}_6$ , (b)  $\text{Sb}_{1.99}\text{Y}_{0.01}\text{Si}_2\text{Te}_6$ , (c)  $\text{Sb}_{1.98}\text{Y}_{0.02}\text{Si}_2\text{Te}_6$ , (d)  $\text{Sb}_{1.97}\text{Y}_{0.03}\text{Si}_2\text{Te}_6$ .

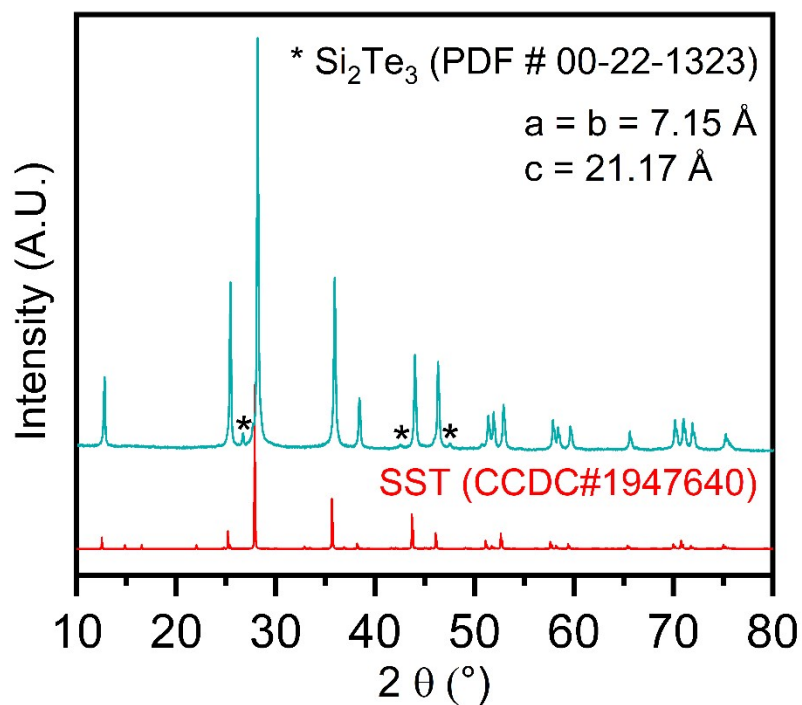


Fig. S5 Powder X-ray diffractogram of  $\text{Sb}_{1.96}\text{Y}_{0.04}\text{Si}_2\text{Te}_6$  spanning from  $2\theta=10-80$

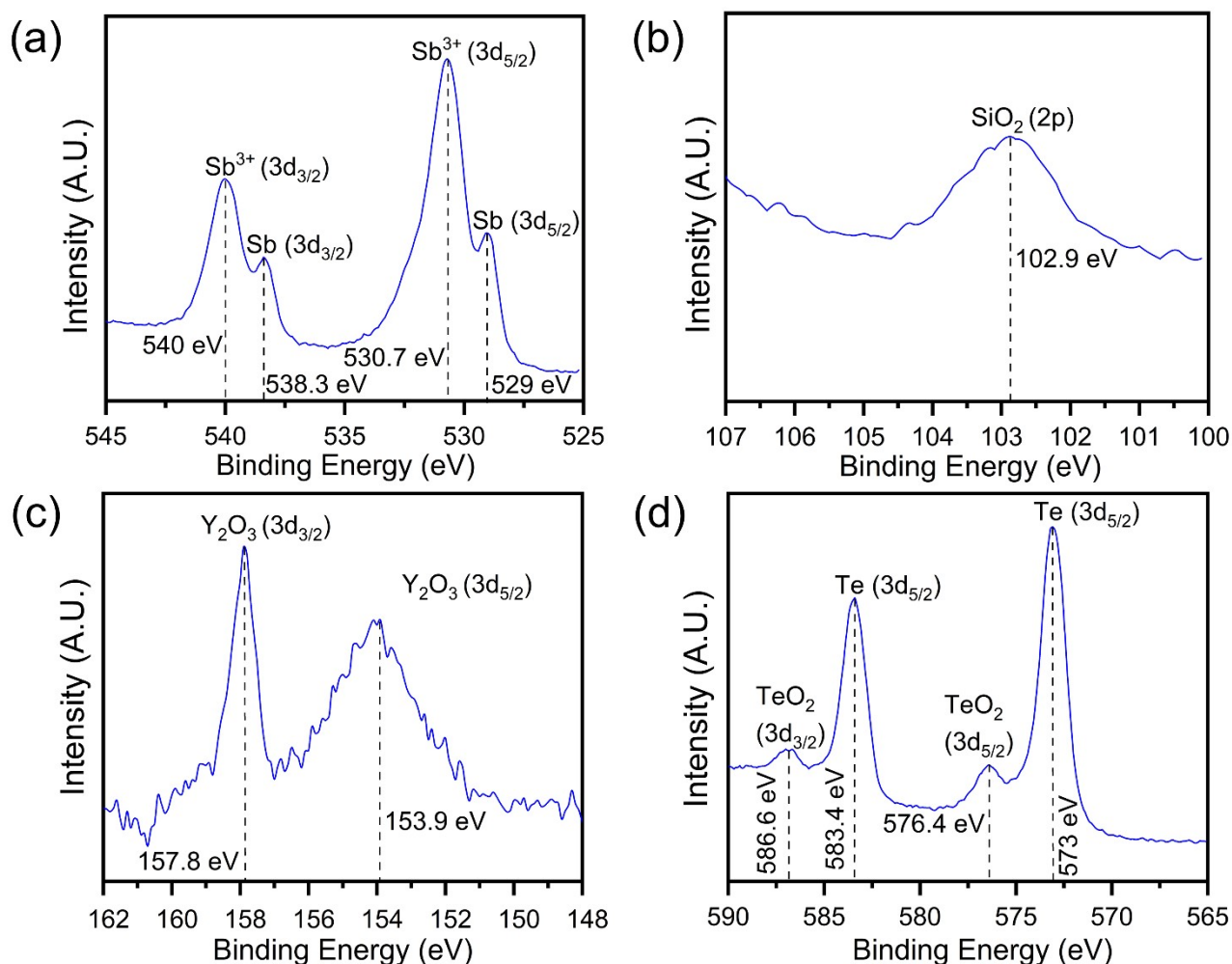


Fig. S6 XPS survey spectra for  $\text{Sb}_{1.98}\text{Y}_{0.02}\text{Si}_2\text{Te}_6$ , reporting binding energies of (a) Sb, (b) Si, (c) Y, and (d) Te

## Lattice Thermal Conductivity Modeling

Lattice thermal conductivity of materials is heavily affected by the Umklapp processes, grain boundaries and point defects. Debye Callaway modeling is useful for revealing the contributions of each phonon scattering mechanism, and has been heavily utilized so far<sup>1</sup>. In this model, the lattice thermal conductivity is calculated through integrating the spectral lattice thermal conductivity ( $\kappa_s$ ) over the whole frequency range, as in Equation 1. Table S3 shows the values of parameters whose calculations are not explained in this chapter.

$$\kappa_s(\omega) = \frac{1}{3} \int_0^{\omega_D} C_s(\omega) v^2 \tau(\omega) d\omega \quad (1)$$

Here,  $\omega$ ,  $C_s(\omega)$ ,  $v$ , and  $\tau$  refer to the phonon frequency, spectral heat capacity, average speed of sound, and total phonon relaxation time respectively.

The phonon frequency,  $\omega$ , is calculated as follows:

$$\omega = \left( \frac{6\pi^2}{\Omega} \right) v \quad (2)$$

Here,  $\Omega$  refer to average atomic volume. The average speed of sound ( $v$ ) has the contributions from transverse ( $v_T$ ) and longitudinal ( $v_L$ ) speed of sound, calculated as follows:

$$v = \left[ \frac{1}{3} \left( \frac{1}{v_L^3} \right) + \left( \frac{2}{v_T^3} \right) \right]^{-1/3} \quad (3)$$

The spectral heat capacity ( $C_s$ ) could be expressed as follows:

$$C_s(\omega) = \frac{3k_B\omega^2}{2\pi^2v^3} \quad (4)$$

To calculate the total phonon scattering rate ( $\tau^{-1}$ ), the individual phonon scattering rates of all scattering mechanisms should be summed up as follows:

$$\tau^{-1} = \tau_U^{-1} + \tau_{GB}^{-1} + \tau_{PD}^{-1} \quad (5)$$

Here,  $\tau_U^{-1}$ ,  $\tau_{GB}^{-1}$ , and  $\tau_{PD}^{-1}$  refer to the Umklapp, Grain boundary, and Point defect scattering rates, respectively.

The Umklapp phonon scattering rate is calculated as follows:

$$\tau_U^{-1} = A_N \cdot \frac{2}{(6\pi^2)^{1/3}} \cdot \frac{k_B\Omega^{1/3}\gamma^2\omega^2T}{Mv^3} \quad (6)$$

Here,  $\gamma$ , and  $M$ , and  $A_N$  refer to Grüneisen parameter, average atomic mass, and the integration coefficient between Umklapp and Normal processes, respectively.

The grain boundary scattering rate is expressed as follows:

$$\tau_{GB}^{-1} = \frac{v}{d} \quad (7)$$

Where  $d$  is the average grain size.

Finally, the point defect scattering rate is calculated through equation 8:

$$\tau_{PD}^{-1} = \frac{\Omega\omega^4}{4\pi v^3} \cdot \Gamma \quad (8)$$

Here,  $\Gamma$  refers to the point defect scattering parameter, and it is manually optimized to find the best fit between modeled and real lattice thermal conductivity.

The thermal conductivity in terms of temperature could be expressed as follows:

$$\kappa_L(T) = \frac{k_B}{2\pi^2v} \left( \frac{k_B T}{\hbar} \right)^3 \int_0^{\theta_D/T} \tau(x) \frac{x^4 \exp(-x)}{[\exp(x) - 1]^2} dx \quad (9)$$

Here,  $k_B$ ,  $\hbar$ , and  $\theta_D$  refer to Boltzmann constant, Planck's constant, and Debye temperature, respectively. "x" could be expressed as follows:

$$x = \frac{\hbar\omega}{k_B T} \quad (10)$$

The Debye temperature,  $\theta_D$ , is calculated as follows:

$$\theta_D = \frac{\hbar\omega}{k_B} \quad (11)$$

### Debye – Cahill Model

Assuming a material has totally an amorphous structure, the lattice thermal conductivity attains a minimum value called as amorphous limit ( $\kappa_{L,min}$ ). This minimum value has been heavily calculated<sup>1-3</sup> by using the following equation.

$$\kappa_{L,min} = \left(\frac{\pi}{6}\right)^{1/3} k_B n_a^{2/3} \sum_i v_i \left(\frac{T}{\theta_i}\right)^2 \int_0^{\theta_i/T} \frac{x^3 e^x}{(e^x - 1)^2} dx \quad (12)$$

Where  $\theta_i$  is expressed as:

$$\theta_i = v_i \left(\frac{\hbar}{k_B}\right) 6\pi^2 n_a \quad (13)$$

Table S3 Parameters used for Debye Callaway and Debye Cahill models.

Symbol	Parameter	Value	Reference
$\Omega$	Average volume per atom	$3.26 \times 10^{-29} \text{ m}^3$	3
$u_L$	Longitudinal sound velocity	2450 m/s	4
$u_T$	Transverse sound velocity	1250 m/s	4
$A_N$	Integration coefficient between Umklapp and Normal scattering processes	2	2
$\Upsilon$	Gruneisen parameter	2.98	2
$\Gamma$	Point defect scattering parameter	0.36	fitted
$n_a$	Number density of atoms	$1.06 \times 10^{28} \text{ m}^{-3}$	2

### Modeling of Thermoelectric Figure of Merit

The highest  $zT$  achievable upon the optimization of carrier concentration can be evaluated through the quality factor (B) and reduced Fermi level ( $\eta$ ). This section will elaborate B and  $\eta$ <sup>5</sup>.

#### Quality Factor (B)

Quality factor is a carrier concentration independent property, and can be calculated as follows:

$$B = \left(\frac{k_B}{e}\right)^2 \frac{\sigma_{E0}}{\kappa_L} T \quad (14)$$

Here,  $\sigma_{E0}$  is the electronic transport coefficient which is calculated as follows

$$\sigma_{E0} = \sigma \cdot \exp\left(\frac{|S|}{k_B/e} - 2\right) \quad (15)$$

The knowledge of  $\sigma_{E0}$  helps explain how the intrinsic electrical transport of the material is affected.

### Reduced Fermi level ( $\eta$ ) and Single Parabolic Band (SPB) Model

SPB model assumes that acoustic phonon scattering is the dominant scattering mechanism. According to the SPB model, the Fermi integrals ( $F_i(\eta)$ ) could be calculated as follows<sup>6</sup>:

$$F_i = \int_0^{\infty} \frac{\epsilon^i d\epsilon}{1 + \exp\left(\frac{\epsilon - \eta}{k_B T}\right)} \quad (16)$$

Here,  $\epsilon$  and  $\eta$  refer to reduced energy of the carrier and the reduced Fermi energy, respectively. The reduced Fermi energy is expressed as follows:

$$\eta = \frac{E_F}{k_B T} \quad (17)$$

Despite carrier concentration measurements prone to inaccuracies due to magnetic field, the reduced Fermi energy could be calculated by using the Seebeck coefficient of the material, through using the following formula:

$$S(\eta) = \mp \frac{k_B}{e} \left[ \eta - \frac{\left(r + \frac{5}{2}\right) F_{r+1.5}(\eta)}{\left(r + \frac{3}{2}\right) F_{r+0.5}(\eta)} \right] \quad (18)$$

After finding the reduced Fermi energy values corresponding to Seebeck coefficient values, the Lorenz number of each sample at various temperature points could be calculated using the following formula.

$$L(\eta) = \left(\frac{k_B}{e}\right)^2 \left[ \frac{\left(r + \frac{7}{2}\right) F_{r+1.5}(\eta)}{\left(r + \frac{5}{2}\right) F_{r+0.5}(\eta)} - \frac{\left(r + \frac{5}{2}\right) F_{r+1.5}(\eta)}{\left(r + \frac{3}{2}\right) F_{r+0.5}(\eta)} \right] \quad (19)$$

The Lorenz number values obtained here were used to calculate the electronic thermal conductivity of the samples in this study.

$$\kappa_e = L \cdot \sigma \cdot T \quad (20)$$

Finally, the thermoelectric figure of merit ( $zT$ ) in terms of reduced Fermi energy is calculated through the following formula:

$$zT(\eta) = \frac{S^2 \eta}{\frac{(k_B/e)^2}{B_{TE} \cdot F_{r+0.5}(\eta)} + L(\eta)} \quad (21)$$

The quality factor values obtained by equation (16) could be added to the plot of  $zT$  vs  $\eta$  to comment on possible mechanisms to enhance the  $zT$  values.



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